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APPLICANTS

Shunpei Yamazaki, Atsugi-shi, JAPAN;
 Hisashi Ohtani, Atsugi-shi, JAPAN;
 Koichiro Tanaka, Atsugi-shi, JAPAN; Kenji Kasahara, Atsugi-shi, JAPAN;
 Ritsuko Kawasaki, Atsugi-shi, JAPAN;

*** CONTINUING DATA ***** AC
 This application is a DIV of 09/932,935 08/21/2001 PAT 6,753,212 AC
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** FOREIGN APPLICATIONS ***** AC
 JAPAN 11-229518 08/13/1999 AC
 JAPAN 11-250940 09/03/1999 AC

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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged Examiner's Signature: <i>[Signature]</i> Initials: <i>[Initials]</i>				

ADDRESS
 31780
 ERIC ROBINSON
 PMB 955
 21010 SOUTHBANK ST.
 POTOMAC FALLS, VA
 20165

TITLE
 LASER APPARATUS, LASER ANNEALING METHOD, AND MANUFACTURING METHOD OF A SEMICONDUCTOR DEVICE

☐ All Fees